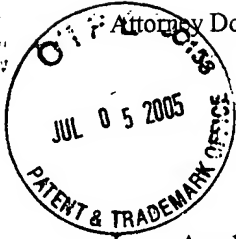


IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Balgovind K. Sharma
 Serial No.: 10/618,228
 Filing Date: 07/11/03
 Examiner: Binh X. Tran
 Art Unit: 1765
 Title: MICELLAR TECHNOLOGY FOR POST-ETCH RESIDUES

CERTIFICATION OF MAILING UNDER 37 C.F.R. 1.8	
I hereby certify that I have caused the documents indicated herein to be deposited with the United States Postal Service to Addressee under 37 CFR 1.8 on the date indicated below and address to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
Date:	6-30-05
Signature:	<i>Mary Schnaiter</i>
Printed Name:	Mary Schnaiter

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

RESPONSE AND AMENDMENT

Dear Sir:

This paper is being submitted in response to the Office action dated June 24, 2005.

Amendments to the Specification:

No amendments to the specification are included with this response.

Amendments to the Claims are reflected in the listing of claims which begins on Page 3 of this paper.

Amendments to the Drawings: No amendments to the drawings are included with this response.

Remarks/Arguments begin on page 8 of this paper.